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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AUG 2 8 2006

| Applicant: | Sung Chul Kang, et al. |)) Group Art Unit: 1752 |
|--|------------------------|-------------------------------|
| Serial No.: | 10/750,845 |) |
| Filed: | January 5, 2004 |)) Examiner: Chu, John S. Y. |
| For: PHOTORESIST COMPOSITION FOR MULTIMICRO NOZZLE HEAD COATER | |) |

AMENDMENT AND RESPONSE

VIA FACSIMILE TO: 1-571-273-8300

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is an amendment and response to the Office Action dated June 27, 2006.

Please amend the application as follows: